

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED <u>TR3</u> Q.A. <u>BYM</u>	

APPLICATION NO. 09/889838	CONT/PRIOR D F	CLASS 216	SUBCLASS 67*	ART UNIT 1746	EXAMINER A. L. Olson
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CANDIDATES

Plasma etching method giving pulsed substrate electrode power

TIME

PTO-2040
12/89

ISSUING CLASSIFICATION

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